Infrared absorption by conical silicon microstructures made in a variety of background gases using femtosecond-laser pulses

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Fabrication of conical microstructures

Optical properties of structures made in SF6

- high absorptance
- explanations

Structures made in other ambient gases

- morphology
- optical and optoelectronic properties

Si (111) placed in background of SF₆



irradiate with 100 fs, 10 kJ/m² laser pulses in SF₆



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Irradiated silicon appears black





20 µm



 $4\,\mu m$

Optical properties

Ordinary silicon



Only wavelengths < 1.1 μm are absorbed



1-2 μm







10 - 12 μm

18 - 20 μm









Total integrated transmittance



Total integrated transmittance











What causes the absorption?

Why such high absorptance?

Microstructure shape can increase absorption



Why such high absorptance?

Secondary ion mass spectrometry

- High concentration of sulfur (~ 10²⁰ cm⁻³)
- Fluorine (~ 10¹⁷ cm⁻³)

Why such high absorptance?

Sulfur adds states in Si band gap



States in gap allow subgap absorption

Effects of different ambient gases



10 µm











Below band gap photocurrent

Below band gap photocurrent

Avalanche photodiode response at 1.3 μ m



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Conclusions

- Up to 90% infrared absorption
 increased infrared photocurrent
- Absorption dependent on ambient gas
- Applications in infrared photodetectors, silicon solar cells, other possible devices

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for more information, see: Appl. Phys. Lett. 78, 1850 (2001). http://mazur-www.harvard.edu

Reflectance



Reflectance



Transmittance



Transmittance



irradiate with 100 fs, 10 kJ/m² laser pulses in SF₆

